

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kevin J. Orvek

Art Unit : 2823

Serial No. : 10/814,883

Examiner : Jarrett J. Stark

Filed : March 31, 2004

Confirmation No: 7571

Title : REAL-TIME MONITORING OF PARTICLES IN SEMICONDUCTOR
VACUUM ENVIRONMENT

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO FINAL ACTION OF JULY 12, 2006

Please amend the above-identified application as follows: